•			#5/A10031				
	OSURE STATEMENT (c))	Docke No. o Okt.813					
In Re Application Of: N	oriyuki MIURA	<u> </u>	071 U.S.				
Serial No. NEW	Filing Date MARCH 8, 2002	Examiner TO BE ASSIGNED	Group Art Unit TO BE ASSIGNED				
Title: METHOD OF MA	NUFACTURING SEMICONDU	CTOR DEVICE AND SEMICOND	UCTOR DEVICE				
	Assistant Com	ddress to: Imissioner for Patents Iton, D.C. 20231					
The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.							
	37 C	FR 1.97(c)					
2.  The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:							
☐ the stateme	ent specified in 37 CFR 1.97(e);						
	OR						
☐ the fee set	forth in 37 CFR 1.17(p).						

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))				Docket No. OKI.313				
In Re Application: Noriyuki MIURA								
Serial No. Filing Date Examiner Group								
NEW	TO BE ASSIGNED	TO BE ASSIGNED						
METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR								
Payment of Fee  (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))  A check in the amount of is attached.  The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. as described below. A duplicate copy of this sheet is enclosed.								
☐ Charge th☐ Credit an	ne amount of y overpayment. ny additional fee required.	Kilo onologod.						
Certificate of	Transmission by Facsimile*	Certificate of Mailin	ng by F	First Class Mail				
I certify that this docum account is being facsin Patent and Trademark (Date)	I certify that this document and fee is being deposited with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.							
	Signature of Person Mailing Correspondence							
Typed or Printed N	Typed or Printed Name o	yped or Printed Name of Person Mailing Certificate						
*This certificate may only be used if paying by deposit account.  Dated: MARCH 8, 2002  Signature  ADAM C. VOLENTINE  REG. NO. 33,289								
VOLENTINE FRANCOS, 12200 SUNRISE VALLEY RESTON, VA 20191 TEL. NO.: (703) 715-0870	Z DRIVE, SUITE 150							
CC: (703) 713-0870	•							

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)			OKI.313 Applicant(s) N riyuki MIURA		Group Art Unit Unknown		
			Filing Date March 8, 2				
			ι	J.S. PATENT DOCUMENTS			Je
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
71							
	<u>L</u>	· · · · · · · · · · · · · · · · · · ·	F	OREIGN PATENT DOCUMENTS	<u> </u>		
	REF DOCUMENT NUMBER DATE			COUNTRY	CLASS	SUBCLASS Tran	Translation
-							YES NO
	<u> </u>		0	THER DOCUMENTS (Includin	g Author, Title, D	ate, Pertinent Pag	ges, Etc.)
	A	Jeffrey W. Thomas et al Oct. 1995, pgs. 116-117.	., "Characteristics (	of Submicrometer LOCOS Isol	ntion", 1995 IE	EE Internationa	al SOI Conference,
EXAMINE	R			DATE CONSIDERED			
EXAMINE	R: Initial i	f citation considered, whether o	or not citation is in con	nformance with MPEP Section 609:	Draw line throu	gh citation if not	in conformance and
orm RTO		-Fy term man meat		POSA/PEVOA	Will All Bollows	Calabridge East	DETMENT OF COMMERCE